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CONFIRMATION NO. 9147

<b>SERIAL NUMBER</b> 10/520,099	<b>FILING OR 371(c) DATE</b> 01/04/2005 <b>RULE</b>	<b>CLASS</b> 117	<b>GROUP ART UNIT</b> 1765	<b>ATTORNEY DOCKET NO.</b> 122336	
<b>APPLICANTS</b> Ryoji Hoshi, Fukushima, JAPAN; Susumu Sonokawa, Fukushima, JAPAN;  <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/08671 07/08/2003  <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-204703 07/12/2002					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>[Signature]</i> <i>F.H.</i> Examiner's Signature Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 6	<b>TOTAL CLAIMS</b> 29	<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> 25944					
<b>TITLE</b> Silicon wafer for epitaxial growth, epitaxial wafer, and its manufacturing method					
<b>FILING FEE RECEIVED</b> 1350	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		